LIST	OF ART CITE	ATTY, DOCKET NO. HTI-0189		APPLN. SERIAL NO. 10/539,762				
(PTO-1449)				APPLICANT(S) Eun-Jeong CHOI				
				FILING DATE June 20, 2005		GROUP 2166		
	35	Ü.S.	PATENT DOC	UMENTS				
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME		CLASS	SUBCLASS	FILING DATE	
		U.S. PATENT	 - APPLICATION	PUBLICATIONS				
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT		CLASS	SUBCLASS		
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NATION NAMED IN COLUMN	J 2005/0056444	12/27/2001	Ide et al. PATENT APPLI	CATIONS	Clarify almostic	erial a - Service annua	anco-Sideli	Sconer
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EXAMINER	DATE CONSIDERED							

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

(I/F84/Documents/2019/3019-935/42234 doc